

3072105-0 PTO
10/04/2006
01/16/02

JL3-883

BEST AVAILABLE COPY

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10047706	FILING DATE 01/15/2002	CLASS 257	SUBCLASS	GAU 2814	EXAMINER
**APPLICANTS: Chung Jeong-Hee; Park In-Sung; Yeo Jae-Hyun;					
**CONTINUING DATA VERIFIED: <i>None</i> <i>TN</i>					
** FOREIGN APPLICATIONS VERIFIED: <i>TN</i> REPUBLIC OF KOREA 01-3165 01/19/2001					
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no		5649-919	
Verified and Acknowledged Examiners's initials		<i>TN</i>			
TITLE : Semiconductor capacitors having tantalum oxide layers and methods for manufacturing the same					
U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner		CLAIMS ALLOWED	
				Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner		DRAWING	
Amount Due	Date Paid			Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Application Examiner	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)